Less Noisy & Highly Sensitive Graphene N-pores for Ultra-fast DNA Sequencing

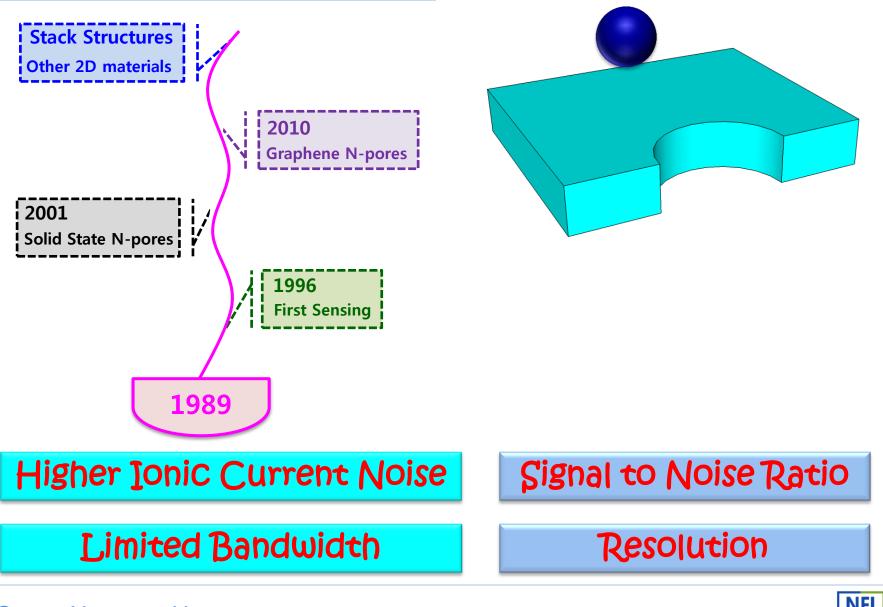
Dr Ashvani Kumar

Nano Fabrication Laboratory Department of Materials Science and Engineering Seoul National University





Origin & Concept of Nanopore



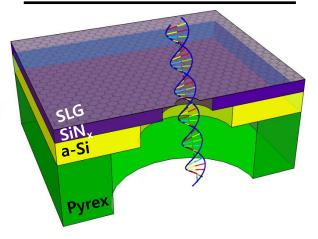
Nano Fabrication Lab

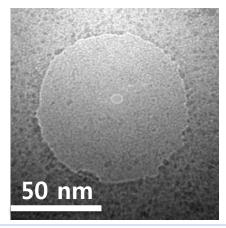
Approach towards improving solid-state nanopores

Si	Pyrex
SiN	→ Graphene

Materials	Dimessions	Purpose
a-Si/Pyrex	Pore size (5x5 μm²)	 ✓ Dielectric noise reduction
SiN _x	Th. = 20 nm	Reduces: ✓ Graphene layer fluctuations
Sirty	Φ = 70-80nm	✓ Pin-hole effects
Graphene	0.3-3.0nm	✓Improved spatial resolution
	Φ= 5-6 nm	✓Better sensing capability

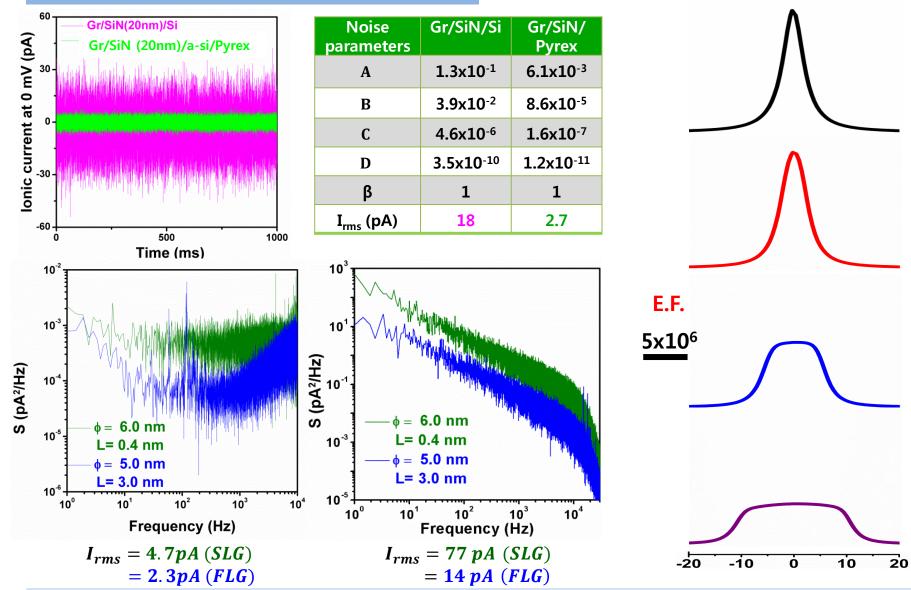
Materials	3	D _{loss}
Si	11.8	5~15×10 ⁻³
Pyrex	4.6	1×10 ⁻³







Improved noise characteristics and temporal resolution





Summary

- ✓ Pyrex based device posses low noise level as compared to Si based device
- ✓ This graphene nanopore presents lower noise level than reported
- ✓ Few layer graphene shows
 - Low noise level
 - Better SNR
 - Increased blockade current
 - Better mechanical stability and easy pore formation



